

Notice of References Cited			Application/Control No.	Applicant(s)/Patent Under Reexamination	
			10/542,260	AN, CHI-YUP	
Examiner			Art Unit	Gail Verbitsky	
			2855	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,915,415	06-1999	Huang, Tien-Tsai	137/551
*	B	US-6,641,305	11-2003	Wang, David	374/148
*	C	US-4,630,940	12-1986	Ostertag et al.	374/148
*	D	US-7,000,850	02-2006	Lin, Pik Fan	236/94
*	E	US-7,246,941	07-2007	Shike, David	374/148
*	F	US-2002/0097777	07-2002	Ronci, Michael Benjamin	374/157
*	G	US-4,743,120	05-1988	Bowen, John G.	374/147
H	US-				
I	US-				
J	US-				
K	US-				
L	US-				
M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.